#### Optimizing Automated Particle Analysis for Forensic Applications

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## The Big Picture

- X-ray Microanalysis
  - Electron Probe Microanalysis (EPMA)
  - Energy Dispersive X-ray Microanalysis (XEDS)
  - Microanalysis of challenging samples
    - Particles, fibers, films, inclusions, ...
  - Microanalysis of particle data sets
- Customers
  - Material science, forensics, manufacturing,



# HIGH SPEED AUTOMATED ANALYSIS OF PARTICLES USING SEM/EDS

- High Speed 10,000+ particle data sets
  - Moderate quality analyses of many particles
  - Search for a needle-in-a-haystack
- Automated Configure, start then no operator intervention
  - Minimize operator bias
  - Reduce tedium
- Analysis -



– Images and quantitative elemental analysis



# MAJOR TIME SINKS

- Stage motion Tiling, stage speed
- Searching Search pixel size, pixel dwell
- Measuring Accuracy & pixel dwell
- Compositional Analysis Limits-of-detection
- Mapping Pixel dwell, area
- Overhead

- QC

# Strategies for Optimizing Stage Movement

- Speed up the stage
  - Particularly backlash removal jogs, post-move vibration
- Minimize stage movement
  - Move in serpentine
  - Subsets

- Fixed size Order frames to produce shortest path
- Unknown size Can't optimize path
- Electronic fields Move beam not stage

# Optimizing the Backscatter Detector

- Consider a probe current of 1 nA and a dwell of 1  $\mu s$ 

-  $(1 \text{ nA})(1 \mu \text{s}) = (6.241 \times 10^{18} \text{ e}^{-/\text{s}})(10^{-9})(10^{-6} \text{ s}) = 6,200 \text{ e}^{-1}$ 

- Typical backscatter coefficients range from 5% to 50%
- If we could collect every electron from

-  $\Delta I/I = (3,100)^{1/2}/(3,100) = 1.8\%$ 

• We actually collect about 14%

$$-\Delta I/I = (430)^{1/2}/(430) = 4.8\%$$

$$-\Delta I/I = (43)^{1/2}/(43) = 15\%$$





1 nA on Cu

## Optimizing EDS

- Maximize solid angle
  - Large area
  - In close
- Many angles better than one
  - Multiple detectors
- Many pulse processors better than one
  - Multiple pulse processors





## Oxygen in Iron Oxide Particles



Detector 2



Sum



Detector 3



Detector 4





Detector 1

An SEM:

- Collects images pixel-by-pixel, row-by-row
- Can stop the raster anywhere
- Can change directions



• We can size a particle quickly regardless of whether it is large or small.

• The "coord-raster" can be used to keep the beam on the particle while collecting EDS.

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### AN SEM IS NOT A CAMERA – PART 2



An SEM can:

• Dynamically change pixel spacing

• Search on a large pixel spacing

• Measure on a fine pixel spacing

Search Measure



An SEM can:

- Raster the beam outside the nominal field-of-view
- Naturally handle particles that fall on a field edge.

Search Measure





#### DOES IT MATTER?

	Dimensions		Timing	Precision		
						Time for
					Overhead	100 particle
	Search	Measure	Search		per particle	field
	Pixels	Pixels	(seconds)		(seconds)	(seconds)
Naive	2048	2048	4.194	1 part in 2048	0	4.19
Optimized	256	2048	0.066	1 part in 2048	~0.025	2.57

OptimizedParticles are sized and a spectrum collected as soon as discoveredNaiveParticles are sized and spectrum collected at the end-of-frame

Fewer small particles are lost during analysis using the optimized algorithm.

### Does it work?

#### OLD

- 1,000 particle / hour
- Search: 99.4 mm<sup>2</sup> in 42 minutes at 1 µm pixel spacing
- Size: 10 particles / s
  - Quantify: 0.3 particles / s

# NEW

- 7,500 particles / hour
- Search: 100 mm<sup>2</sup> in 13 minutes at 1 µm pixel spacing
- Size: 18 particles / s
- Quantify: 2.5 particles / s

#### TYING IT ALL TOGETHER



# A Final Word on QC

1) EDS

#### 2) Imaging detectors

#### 3) Magnification







2'0

#### 4) Probe current